

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			ATTY. DOCKET NO. M122-1114		SERIAL NO. 09/233,377	
<div style="position: relative; width: 100px; height: 100px; margin: 0 auto;"> <div style="position: absolute; top: 0; left: 0; right: 0; bottom: 0; border: 1px solid black; border-radius: 50%; text-align: center; line-height: 100px;"> DIPE AUG 27 2001 PATENT & TRADEMARK OFFICE </div> </div> <p style="margin-top: 5px;">LIST OF ARTS CITED BY APPLICANT (Attach several sheets if necessary)</p>					APPLICANT Micron Technology, Inc.			
					FILING DATE January 18, 1999		GROUP 2813	
U.S. PATENT DOCUMENTS								
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate		
TSP	AA	6,090,708	Sandhu et al.	438	683	2/1998		
	AB							
	AC							
	AD							
	AE							
	AF							
	AG							
	AH							
	AI							
	AJ							
	AK							
FOREIGN PATENT DOCUMENTS								
	Document Number	Date	Country	Class	Subclass	Translation		
						Yes	No	
	AL							
	AM							
	AN							
	AO							
	AP							
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AR							
	AS							
	AT							
EXAMINER								
		DATE CONSIDERED		12/17/01				
<small>*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.</small>								

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MJ22-1114		SERIAL NO. 09/233,377	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Micron Technology, Inc.		FILING DATE January 18, 1999	
				GROUP 2813			

OIPE
FEB 19 2002
PATENT & TRADEMARK OFFICE

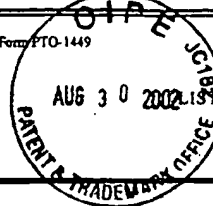
U.S. PATENT DOCUMENTS							
*Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA						
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS							
	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No
	AL						
	AM						
	AN						
	AO						
	AP						

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
TS?	AR		Merriam Webster's Collegiate Dictionary - Ten Edition . ©1996, page 827 (3 pages total).
	AS		
	AT		

EXAMINER 	DATE CONSIDERED 5/4/02
--------------	---------------------------


*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-1449 <div style="text-align: center;">  </div>		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1114		SERIAL NO. 09/233,377	
PRIOR ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Micron Technology, Inc.		FILING DATE January 18, 1999	
GROUP 2813							

U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
TS	AA	6,376,372 B1	04/23/02	Paronje et al.			
TS	AB	4,897,368	01/30/90	Koboshi et al.			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Subclass	Translation
							Yes No
	AL						
	AM						
	AN						
	AO						
	AP						

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
TS	AR		Omar, M. Ali. "Elementary Solid State Physics." © 1975 by Addison-Wesley Publishing Company, Inc., pages 539-542 (6 pages total).
TS	AS		Wolf, et al., "Silicon Processing for the VLSI Era - Volume 1-Process Technology," ©1986 by Lattice Press, pages 242, 261, 262, 303, & 304 (7 pages total).
	AT		

EXAMINER 	DATE CONSIDERED 4/4/03
--	------------------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Form PTO-101 U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. M122-1114		SERIAL NO. 09/233,377	
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT Micron Technology, Inc.	
				FILING DATE January 18, 1999	
				GROUP 2813	

U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
TSP	AA	4,378,628	04-1983	Levinstein et al.			
TSP	AB	6,054,387	04-2000	Fukuda			
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AL							
	AM							
	AN							
	AO							
	AP							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)			
AR			
AS			
AT			

EXAMINER	DATE CONSIDERED 12/29/03
----------	--------------------------

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.